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Inventor Information

Inventor One Given Name:: Hideki
Family Name:: KOMATSUDA
Name Suffix::
City of Residence:: Kawasaki-shi
State or Prov. of Residence::
Country of Residence:: Japan
Inventor Two Given Name::
Family Name::
Name Suffix::
City of Residence::
State or Prov. of Residence::
Country of Residence::
Inventor Three Given Name::
Family Name::
Name Suffix::
City of Residence::
State or Prov. of Residence::
Country of Residence::
Inventor Four Given Name::
Family Name::
Name Suffix::
City of Residence::
State or Prov. of Residence::
Country of Residence::
Inventor Five Given Name ::
Family Name::
Name Suffix::
City of Residence::
State or Prov. of Residence::
Country of Residence::

Correspondence Information

Name Line One:: Oliff & Berridge PLC
Address Line One:: P.O. Box 19928
City:: Alexandria
State or Province:: VA
Postal or Zip Code:: 22320
Telephone:: (703) 836-6400
Fax:: (703) 836-2787
Electronic Mail:: commcenter@oliff.com

Application Information

Title Line One:: EXPOSURE APPARATUS AND METHOD OF
Title Line Two:: FABRICATING A MICRO-DEVICE USING
Title Line Three:: THE EXPOSURE APPARATUS
Title Line Four::



Total Drawing Sheets:: 21
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Continuity Information

>This application is a:: Continuation-In-Part of
Application One:: 09/259,137
Filing Date:: February 26, 1999
Patent Number::
which is a::
>>Application Two::
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Prior Foreign Applications

Foreign Application One:: 2000-050137
Filing Date:: February 25, 2000
Country:: Japan
Priority Claimed:: Yes
Foreign Application Two:: 10-47400
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Country:: Japan
Priority Claimed:: Yes
Foreign Application Three:: 10-263673
Filing Date:: September 17, 1998
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Priority Claimed:: Yes

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